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JGW

Patent

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant(s): Hong-Kyu PARK, et al. ) Re: Information Disclosure  
Serial No.: 09/913,428 ) Statement  
Filed: August 14, 2001 ) Group: 1754  
For: "A METHOD FOR PREPARING LITHIUM ) Our Ref: B-4264PCT 618979-7  
MANGANESE SPINEL OXIDE..." )  
  ) Date: May 13, 2004

Commissioner for Patents  
P.O. Box 1450  
Alexandria VA, 22313-1450

Sir:

In accordance with the Applicants' duty to disclose information which may be material to the examination of this application, the undersigned respectfully requests that the Examiner consider on the merits the documents listed on the enclosed Form PTO-1449 (modified) before issuing the next Office Action on the merits. We are enclosing herewith a copy of each document listed on the enclosed Form PTO-1449 (modified).

The filing of this Information Disclosure Statement (IDS) shall not be construed as a representation that a search has been made (37 C.F.R. 1.97(g)), an admission that the information cited is, or is considered to be, material to patentability, or that no other material information exists.

The documents listed on the enclosed Form PTO-1449 (modified) include those cited in the Japanese Official Action, issued on February 24, 2004, for the corresponding Japanese Patent Application No. JP 2001-545204. A copy of the Official Action (2 pages) is enclosed herewith.

The documents listed on the enclosed Form PTO-1449 (modified) include those cited in the english translation of the Chinese Official Action, issued on April 10, 2004, for the corresponding

Information Disclosure Statement  
USSN 09/913,428  
May 13, 2004  
Page 2

Chinese Patent Application No. CN 00803797.3. A copy of the Official Action (3 pages) is enclosed herewith.

Japanese Document No. 2000-123876 is not in English. A concise English-language explanation of the relevance of Japanese Document No. 2000-123876 can be found in the enclosed English-language abstract.

Each item of information contained in this IDS was first cited in the enclosed Official Action of the corresponding Japanese and Chinese applications (which were mailed on February 24, 2004 and April 10, 2004) not more than three months prior to the filing of this IDS. Therefore, no fees should be due. The Examiner is requested to consider this IDS on the merits.

This paper is not being filed as a response to the Office Action issued March 1, 2004. A response to that Office Action will be made with a separate filing.

The filing of this Information Disclosure Statement shall not be construed as an admission against interest in any manner. (Notice of January 9, 1992, 1135 O.G. 13-25, at 25.) Also, the filing of this Information Disclosure Statement does not constitute a response to the pending Office Action, mailed March 1, 2004.

Information Disclosure Statement  
USSN 09/913,428  
May 13, 2004  
Page 3

The person making this statement is the practitioner who signs below on the basis of information supplied by an individual associated with the filing and prosecution of this application (37 C.F.R. § 1.56(c)) and on the basis of information in the practitioner's file.

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first-class mail in an envelope addressed to the "Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450", on May 13, 2004 by Shana Morda.



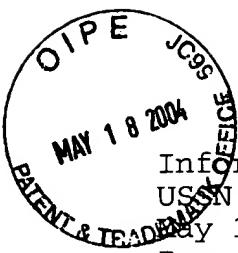
Respectfully submitted,



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Enclosures: Form PTO-1449 (modified) (1 page)  
Copy of Official Action for JP 2001-545204 (2 pages)  
Copy of Official Action for CN 00803797.3 (3 pages)  
Copy of documents listed on Form PTO-1449 (modified)



Information Disclosure Statement  
USSN 09/913, 428  
May 13, 2004  
Page 4

<b>Form PTO-1449 (Modified)</b>	<b>ATTY DOCKET NO.</b> B-4264PCT 618979-7	<b>U.S. SERIAL NO.</b> 09/913, 428
<b>LIST OF PATENTS AND PUBLICATIONS STATEMENT</b>	<b>APPLICANT(S)</b> Hong-Kyu PARK, et al.	
	<b>FILING DATE</b> August 14, 2001	<b>GROUP</b> 1754

**U.S. PATENT DOCUMENTS**

EXAMINER INITIAL	DOCUMENT NUMBER	ISSUE DATE	NAME	CLASS	SUBCLASS	FILING DATE or 102(e) DATE IF APPROPRIATE
	5,523,073	06/1996	Sumida et al.	423	605	

**FOREIGN PATENT DOCUMENTS**

	DOCUMENT NUMBER	PUBLICATION DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO
	2000-123876	04/2000	JP			abstract

**OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)**

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<b>EXAMINER</b>	<b>DATE CONSIDERED</b>

**EXAMINER:** Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.